

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


Application Serial No. 09/298,160
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Inventor Dan G. Custer et al.
Assignee Micron Technology, Inc.
Group Art Unit 1746
Examiner A. Olsen
Attorney's Docket No. MI22-1172
Title: Polishing Systems, Methods of Polishing Substrates, and Methods of Preparing
Liquids for Semiconductor Fabrication Processes

Assistant Commissioner of Patents
Washington, D.C. 20231

ASSOCIATE POWER OF ATTORNEY

Please recognize Jennifer J. Taylor, Ph.D. (Reg. No. 48,711), Frederick M. Fliegel, Ph.D. (Reg. No. 36,138), Donald B. Kenady (Reg. No. 40,045), James E. Lake (Reg. No. 44,854), and Bernard Berman (Reg. No. 37,279), whose post office address is 601 W. First Avenue, Suite 1300, Spokane, Washington 99201-3828, as an associate attorney or agent in the above-entitled application.

Date: 1/15/02


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